

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Shouji YAJIMA et al.

Application No.: 10/725,362

Filed: December 3, 2003

For: PRODUCTION METHOD OF SYNTHETIC SILICA GLASS AND THERMAL
TREATMENT APPARATUS



MAIL STOP RCE

Group Art Unit: 1731

Examiner: C. LOPEZ

Docket No.: 109067.01

**LARGE ENTITY REQUEST FOR
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. §1.114, Applicants hereby request continued examination.

☒ Applicants further request entry and consideration of the submission filed May 22, 2007.

The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 193548 in the amount of ☒ \$790.00 as payment of the fees set forth in 37 C.F.R. §1.17(e). The Commissioner is hereby authorized to charge any additional fees or credit any overpayment associated with this communication to Deposit Account No. 15-0461.

Respectfully submitted,

Mario A. Costantino
Registration No. 33,565

MAC/ccs

Date: June 8, 2007

OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400

**DEPOSIT ACCOUNT USE
AUTHORIZATION**

Please grant any extension
necessary for entry;
Charge any fee due to our
Deposit Account No. 15-0461

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